



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

)

Shunpei YAMAZAKI et al.

) Group Art Unit: 2811

Serial No. 09/535,015

) Examiner: S. Crane

Filed: March 24, 2000

)

For: METHOD OF MANUFACTURING)  
A SEMICONDUCTOR DEVICE )

)

#10  
Election  
F JONES  
8-2-02

<b>CERTIFICATE OF MAILING</b>	
I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on	
<i>7/22/02</i>	

**RESPONSE TO ELECTION REQUIREMENT**

Honorable Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the election requirement in the Office Action of June 18, 2002, Applicants hereby elect with traverse species I, a semiconductor film containing hydrogen or halogen. Claims 2-14 and 21 are readable thereon. Furthermore, Applicants note that independent claim 29 recites a semiconductor film containing a hydrogen and independent claim 35 recites a semiconductor film containing a halogen. Thus, it is believed that claims 29-43 should also be examined with species I.

Examination on the merits is requested.

Respectfully submitted,

  
Eric J. Robinson  
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